

AUG 08 2005

RESPONSE UNDER ~~37 CFR~~ 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2826

PATENT APPLICATION
Doc. No.: 4591-366
Client Ref. No.: IC12242-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Jeong-Min CHOI and Tae-Hong HA

Serial No.: 10/750,983 Examiner: Erdem, Fazli

Filed: January 2, 2004 Group Art Unit: 2826

Confirmation No.: 5470

For: SEMICONDUCTOR DEVICE HAVING SILICIDE LAYERS AND
METHOD OF FABRICATING THE SAME

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

This paper is responsive to the Final Office Action, Paper No. 04022005, dated 7
April 2005.

Specification Amendments begin on page 2 of this paper.

A Listing of Claims that reflects the current status of the claims begins on page 4 of
this paper.

Remarks/Arguments begin on page 7 of this paper.